	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Def Definition	Errors
1	IS&R	L8	3686	((359/290,291,295,298,302,311) or (73/720,721,722,723,715) or (216/2) or (438/53)).CCLS.	USPAT; US-PGPUB	2003/10/22 08:53			0
2	BRS	L9	429	8 and (mems or micro-electromechanic$4 or (micro adj electr$4 adj mechanic$4))	USPAT; US-PGPUB	2003/10/22 08:54			0
3	BRS	L10	389	9 and (sacrificial$3 or psg or (phosposilicate adj glass) or polysilicon or silicon)	USPAT; US-PGPUB	2003/10/22 08:55			0
4	BRS	L11	108	10 and transduc$4	USPAT; US-PGPUB	2003/10/22 08:55			0
5	BRS	L12	77	11 and (diaphragm or (silicon adj1 nitride) or (silicon adj1 dioxide))	USPAT; US-PGPUB	2003/10/22 08:56			0
6	BRS	L13	67	12 and ((remov$4 or etch$4) with (sacrificial$3 or psg or (phosposilicate adj glass) or polysilicon or silicon))	USPAT; US-PGPUB	2003/10/22 08:56			0
7	BRS	L15	63	12 and ((remov$4 or etch$4) near3 (sacrificial$3 or psg or (phosposilicate adj glass) or polysilicon or silicon))	USPAT; US-PGPUB	2003/10/22 08:56			0
8	BRS	L14	4	13 and ((diaphragm or (silicon adj1 nitride) or (silicon adj1 dioxide)) with suspend$4)	USPAT; US-PGPUB	2003/10/22 08:57			0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
9	BRS	L16	11	15 and void$3	USPAT; US-PGPUB	2003/10/22 08:57			0

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Def inition	Errors
1	BRS	L1	9116	(mems or (micro-electromechanic$4) or (micro adj electr$4 adj mechanic$4))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 2			0
2	BRS	L2	5730	1 and (sacrificial$3 or psg or (phosposilicate adj glass) or polysilicon or silicon)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 3			0
3	BRS	L3	2692	2 and (diaphragm or (silicon adj1 nitride) or (silicon adj1 dioxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 6			0
4	BRS	L4	781	3 and transduc$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 5			0
5	BRS	L5	612	4 and ((remov$4 or etch$4) with (sacrificial$3 or psg or (phosposilicate adj glass) or polysilicon or silicon))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 5			0
6	BRS	L6	534	4 and ((remov$4 or etch$4) near3 (sacrificial$3 or psg or (phosposilicate adj glass) or polysilicon or silicon))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 5			0
7	BRS	L7	28	6 and ((diaphragm or (silicon adj1 nitride) or (silicon adj1 dioxide)) with suspend$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003 /10/ 22 08:3 6			0